

Advances in transmission electron microscopy

Tom Sharp LeRoy-Eyring Center for Solid State Science Arizona State University

Improving microscope resolution



Resolution of an optical microscope is limited by the diffraction limit: $\delta = 0.6\lambda/nsin\alpha$

Resolution could be improved by reducing the wavelength (λ)

The first electron microscope



FIG. 1. Sketch by the author of the cathode-ray tube for testing the imaging properties of the nonuniform magnetic field of a short coil (Ruska, 1929; Ruska and Knoll, 1931) (footnote 1).



Ruska and Knoll in the 1931.

John Cowley with Sumio lijima



John Cowley with Sumio Iijima at the controls of the JEM-100B (Tempe, 1974)

Layout of a Transmission Electron Microscope



Electron Matter Interactions

- Electrons are easily scattered.
- Elastic scattering
 - no change in energy.
 - diffraction
- Inelastic scattering
 - transferring energy to the sample.
 - Used for microanalysis:



Electron imaging and diffraction



Diffraction Contrast Imaging

- Each diffracted spot corresponds to a set of lattice planes.
 - Each spot contains information from the entire image (selected)
- Bright-Field Imaging
 - Use only the central spot.
- Dark-Field Imaging
 - Use one of the diffracted spots
 - Tilt the crystal to or near a Bragg condition



DF Image of Olivine dislocations, b=[100]

- Complex mixed character
 - Edge and screw dislocations in a (010) foil
 - Slip system [100](010)
- Tilt boundaries along (100)
 - Edge dislocations with u ~ [010]
 - Slip system [100](001)



HRTEM (Phase Contrast)

- Imaging down a zone axis many diffracted beams.
 - Use a large objective aperture.
 - Image of the crystal lattice with nearly atomic resolution
- Phase contrast
 - Contrast from phase differences between the diffracted beams.
- Dynamic diffraction
 - Complex image contrast variations with sample thickness and defocus.



Zircon twin boundary

Phase contrast image alon [111] showing damaged regions that appear lighter.





Zircon twin boundary

Higher magnification image of disordered domains.





Improving TEM resolution



For electron microscope the (Scherzer) resolution is given by

$$\delta = 0.66\lambda^{3/4} \mathbf{C_s}^{1/4}$$

Increase the accelerating voltage to reduce the wavelength.

Historical approach to resolution improvement

Use higher-voltages for shorter wavelengths

Problems:

- Difficult to house a giant TEM
- Electron beam damage

Hitachi 1-MeV FE-HRTEM

Tonomura, J. Electron Micr. 52, 11 (2003)

"World record" lattice fringe spacing

Lattice fringes at 1.0 MeV - beyond 0.5Å



from Kawasaki et al., Appl. Phys. Lett. 76, 1342 (2000)

Improving TEM resolution



For electron microscope the (Scherzer) resolution is given by

$$\delta = 0.66\lambda^{3/4} C_s^{1/4}$$

Modern microscopes correct the C_s

Aberration corrected TEM and STEM

Spherical Aberration

Longitudinal and Transverse Spherical Aberration



Aberration-correction in TEM

Design of the first successful aberration-corrected 200-keV FEG-TEM



GaAs showing individual atomic columns after application of C_s correction. Atoms separated by 1.4 Å



Schematic drawing of aberration correction device placed between objective and diffraction lenses.

from Haider, et al., Ultramicroscopy, 75, 53 (1998)

Aberration-correction in STEM

Allowing use of large objective aperture

- Smaller probe size
- Higher probe current



(Krivanek)

Southwest Center for Aberration Corrected Electron Microscopy

Building designed to meet environmental needs of aberration-corrected STEM/TEM

4-foot thick Isolated foundation for vibration isolation Isolated power with no ground loops in floor or walls Tight temperature control with minimal airflow



Space for four advanced microscopes:

Southwestern Center for Aberration Corrected Electron Microscopy

ASU

Jeol ARM200F

- Aberration-Corrected STEM for Imaging and Spectrum Mapping
 - Operates at 80, 120, and 200 kV.
 - Field-emission electron gun
 - Corrector: CEOS CESCOR
 - STEM resolution @ 200 kV ~ 0.8Å
 @ 80 kV ~ 1.2 Å
 - JEOL EDX Detector (0.24 ster)
 - Gatan Enfinium EELS spectrometer





- Bright-field STEM
- Annular bright-field (ABF)
- Large-angle BF (LABF)
- Low-angle ADF (LAADF)
- Medium-angle ADF (MAADF)
- High-angle ADF (HAADF)

STEM Imaging

- BF: Bright-field; DF: Dark-field
- ABF: annular-bright-field
- MAADF: medium-angle annular-DF
- HAADF: high-angle annular-DF



Simultaneous HAADF and BF images of endotaxially anchored PdZn alloy nanoparticle on ZnO nanowire. Courtesy of Jingyue Liu



Annular-bright-field image and line scan showing onemonolayer-thick InN quantum wells in GaN matrix.

Imaging of a LaMnO₃/SrTiO₃ interface

- Fast collection of EELS spectra combined with STEM imaging
- Atomic-resolution chemical mapping



STEM HAADF image of SrTiO3/LaMnO3 interface, used as survey image for EELS Spectrum imaging

EELS Spectrum Imaging



Chemical mapping across LaMnO₃/SrTiO₃ interface.

Courtesy of Paolo Longo

NION UltraSTEM Monochromated STEM/EELS at 40/60/100kV



O.L. Krivanek et al. Microcopy **62**(1) 3-21 (2013).

Nion high-energy resolution monochromated EELS systems (HERMES)







ATOM-BYATOM ANALYSIS

THE INTERNATIONAL WEEKLY JOURNAL OF SCIENCE

25 March 2010 | www.nature.com/nature | £10

ATOM - BY-ATOM ANALYSIS Elements mapped by annular dark field electron microscopy



From Krivanek, et al. Nature , 29 March, 2010

Boron Nitride phonons: hexagonal vs. cubic



Hexagonal BN

Cubic (zinc blende) BN



SuperSTEM DARESBURY





Aloof beam spectroscopy of radiation sensitive materials



VEELS of C_3N_4 in transmission and aloof modes.

Diane Haiber et al M&M 2016





HAADF images of C₃N₄ and EELS spectrum showing C-K and N-K edges

FEI Titan ETEM

(S)TEM that operates at 80, 200, & 300 kV.

X-FEG:

Ultrahigh-brightness electron gun

Monochromator: Energy resolution ~ 0.15 eV

Imaging Corrector: CEOS CETCOR Information limit @ 300 kV < 0.9 Å @ 80 kV ~ 1.9 Å (mono off) @ 80 kV ~ 1 Å (mono on)

Analytical (S)TEM: EDAX EDX Detector (0.13sr) Gatan Imaging Filter/EELS spectrometer



Low Voltage Imaging

Detonation nanodiamond particles < 3 nm imaged at 80kV using monochromator. Reconstructed surfaces and twins are visible at the atomic level.



Environmental TEM

Environmental TEM: Samples to be exposed to gaseous environment.

TEM allows rapid imaging and movies with atomic resolution.

In-house gas system allows precise control and accurate mixing.

Heating and Cooling Holders: Sample observation at temperatures up to 1100°C or down to -170 °C.



FEI Titan Krios

- FEI Titan Krios with a Gatan K2 Summit single-electron detector
- 2-3Å resolution in biological macromolecules
- Single particle analysis of proteins
- Cryo-electron tomography of cell structures





- Sample is frozen in aqueous solution
 → native conditions
- Frozen state prevents dehydration in microscope vacuum
- Low temperature delays effects of radiation damage



Aligning Particles





Webinar Recordings & Slides

To access this recording and slides



Building College-University Partnerships for Nanotechnology Workforce Development

http://nano4me.org/webinars.php

Or



http://ncisouthwest.org/index.php/webinars/



Thank You!

Thank you for attending the NACK Network & NCI-SW webinar

Please take a moment to complete our survey